PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Chen-Fu Chu	06/26/2013
Hao-Chun Cheng	06/29/2013
Trung Tri Doan	07/05/2013
Feng-Hsu Fan	06/27/2013

RECEIVING PARTY DATA

Name:	SemiLEDs Optoelectronics Co., Ltd.	
Street Address:	3F, No. 11, Ke Jung Road, Chu Nan Site,	
Internal Address:	Hsinchu Science Park	
City:	Chu-nan 350, Miao-Li County	
State/Country:	TAIWAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13936337

CORRESPONDENCE DATA

Fax Number: 3039896538

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

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	PATENT
Signature:	/Stephen A. Gratton/
NAME OF SUBMITTER:	Stephen A. Gratton
ATTORNEY DOCKET NUMBER:	SP032USP1

REEL: 030783 FRAME: 0559

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Date:	07/12/2013
Total Attachments: 2 source=SP032USP1Assignment#page1.tif source=SP032USP1Assignment#page2.tif	

PATENT REEL: 030783 FRAME: 0560

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re applicati	ion of:	
HAO- TRUN	N-FU CHU CHUN CHENG NG TRI DOAN G-HSU FAN	
Serial No.:	13/936,337	
Filing Date:	07-08-2013	
Title:	SEPARATING A	FABRICATING SEMICONDUCTOR DICE BY SUBSTRATE FROM SEMICONDUCTOR USING MULTIPLE LASER PULSES
Docket No.	SP032USP1	
		ASSIGNMENT:
Previo	sed for recording ously recorded	

ASSIGNMENT

FOR GOOD AND VALUABLE CONSIDERATION, the receipt, sufficiency, and adequacy of which are hereby acknowledged, the undersigned do hereby:

SELL, ASSIGN, AND TRANSFER to SemiLEDs Optoelectronics Co., Ltd., a Taiwanese company with its business address at 3F, No. 11, Ke Jung Rd., Chu-Nan Site, Hsinchu Science Park, Chu-nan 350, Miao-Li County, Taiwan, R.O.C. (the "Assignee), the entire right, title, and interest for the United States and all foreign countries, in and to any and all improvements which are disclosed in the application for United States Letters Patent, which will be executed by the undersigned and is entitled: METHOD FOR FABRICATING SEMICONDUCTOR DICE BY SEPARATING A SUBSTRATE FROM SEMICONDUCTOR STRUCTURES USING MULTIPLE LASER PULSES; such application and all divisional, continuing, substitute, renewal, reissue, and all other applications for patent which have been or shall be filed in the United States and all foreign countries on any of such improvements; all original and reissued patents which have been or shall be issued in the United States and all foreign countries on such improvements; and specifically including the right to file foreign applications under the

PATENT REEL: 030783 FRAME: 0561 provisions of any convention or treaty and claim priority based on such application in the United States of America;

AUTHORIZE AND REQUEST, the issuing authority to issue any and all United States and foreign patents granted on such improvements to the Assignee;

WARRANT AND COVENANT that no assignment, grant, mortgage, license, or other agreement affecting the rights and property herein conveyed has been or will be made to others by the undersigned, and that the full right to convey the same as herein expressed is possessed by the undersigned;

COVENANT that, when requested and at the expense of the Assignee, to carry out in good faith the intent and purpose of this assignment the undersigned will execute all divisional, continuing, substitute, renewal, reissue, and all other patent applications on any and all such improvements; execute all rightful oaths, declarations, assignments, powers of attorney, and other papers; communicate to the Assignee all facts known to the undersigned relating to such improvements and the history thereof; and generally do everything possible which the Assignee shall consider desirable for securing, maintaining, and enforcing proper patent protection for such improvements and for vesting title to such improvements in the Assignee;

TO BE BINDING on the heirs, assigns, representatives, and successors of the undersigned and extend to the successors, assigns, and nominees of the Assignee.

Signature <u>Chen</u> In Clun CHEN-FU CHU	Date 20/3.6.26.
Signature Goo-chun Cheng HAO-CHEN CHENG	Date 2013. 6. 29
SignatureTRUNG TRI DOAN	Date >0(3, 7, 5
Signature Feng-Hon Fan FENG-HSU FAN	Date >0/3, 6, 27

Docket No. SSP032USP1